

MNC 2018 (November 13-16, Sapporo Park Hotel, Sapporo, Japan) Schedule

Tuesday, November 13

Room C (The Terrass Room (1F))
13:00-16:45 MNC 2018 Technical Seminar in Japanese EUV Lithography Tutorial
Room F (Park Hall (3F))
17:20-19:20 Get Together Party

Technical Seminar in Japanese Registration Desk
November 13, 12:30 - 16:00 (1F Lobby)

Conference Registration Desk
November 13, 16:00 - 18:30 (1F Lobby)
November 14, 8:30 - 11:30 (1F Lobby)

November 14, 11:40 - 18:30 (B-2F Lobby in front of Room P2)
November 15, 8:30 - 18:00 (B-2F Lobby in front of Room P2)
November 16, 8:30 - 16:00 (B-2F Lobby in front of Room P2)

Wednesday, November 14

Room P1 (Emelald, 3F)			
14P-1: Opening & Plenary Session 9:30-12:10			
Lunch			
Room A (Park Plaza A (B2F))	Room B (Park Plaza D (B2F))	Room C (The Terrace Room (1F))	Room D (Emina (1F))
14A-2: 13:30-15:00 Symp. A: Nano-Metrology for Exploring the Limit I	14B-2: 13:30-14:40 Microsystem Technology and MEMS I	14C-2: 13:30-15:40 NanoTool I	14D-2: 13:30-14:50 Inorganic Nanomaterials I
Author's Interview: None	14B-2 Author's Interview: 16:35-16:45	14C-2 Author's Interview: 15:40-15:50	14D-2 Author's Interview: 16:45-16:55
Room P2 (Park Plaza BC (B2F))			
Coffee Break			
14A-3: 15:15-16:45 Symp. A: Nano-Metrology for Exploring the Limit II	14B-3: 14:55-16:35 Microsystem Technology and MEMS II	14C-3: 16:05-17:15 Nanodevices I	14D-3: 15:05-16:45 Inorganic Nanomaterials II
Author's Interview: None	14B-3 Author's Interview: 16:35-16:45	14C-3 Author's Interview: 17:15-17:25	14D-3 Author's Interview: 16:45-16:55
Room A (Park Plaza D (B2F)) and Room P2 (Park Plaza BC (B2F))			
17:10-17:40 Happy Hour Part I, 17:40-18:40 Happy Hour Part II			

Thursday, November 15

Room A (Park Plaza A (B2F))	Room B (Park Plaza D (B2F))	Room C (The Terrace Room (1F))	Room D (Emina (1F))
15A-4: 9:00-10:50 Resist and Directed Self-Assembly	15B-4: 9:00-10:20 Nanocarbons I	15C-4: 9:00-10:40 Nanodevices II	15D-4: 9:00-10:30 Microsystem Technology and MEMS III
15A-4 Author's Interview: 10:50-11:00	15B-4 Author's Interview: 10:20-10:30	15C-4 Author's Interview: 12:35-12:45	15D-4 Author's Interview: 10:30-10:40
Room P2 (Park Plaza BC (B2F))			
Coffee Break			
15A-5: 11:10-12:40 Electron and Ion Beam Technologies	15B-5: 10:45-12:05 Inorganic Nanomaterials III	15C-5: 10:55-12:35 Nanodevices III	15D-5: 10:55-12:15 Organic Nanomaterials I
15A-5 Author's Interview: 12:40-12:50	15B-5 Author's Interview: 12:05-12:15	15C-5 Author's Interview: 12:35-12:45	15D-5 Author's Interview: 12:15-12:25
Lunch			
15A-6: 14:10-15:40 Photolithography and Patterning	15B-6: 13:50-15:30 Inorganic Nanomaterials IV	15C-6: 13:40-15:50 Symp. C: Thermal and Electronic Properties of Nanoscale Interfaces	15D-6: 13:40-14:40 Organic Nanomaterials II
15A-6 Author's Interview: 15:40-15:50	15B-6 Author's Interview: 15:30-15:40	15C-6 Author's Interview: 15:50-16:00	15D-6 Author's Interview: 14:40-14:50
Room P2 (Park Plaza BC (B2F))			
Coffee Break			
Room P2 (Park Plaza BC (B2F))			
15P-7: 16:00-18:00 Poster Session I Photolithography and Patterning, Electron and Ion Beam Technologies, Resist and Directed Self-Assembly, Nanocarbons, Nanodevices, Nanofabrication, Inorganic Nanomaterials, Organic Nanomaterials, NanoTool and Microsystem Technology and MEMS			
Room P1 (Emelald, 3F)			
18:20-20:20 Banquet			

Friday, November 16

Room A (Park Plaza A (B2F))	Room B (Park Plaza D (B2F))	Room C (The Terrace Room (1F))	Room D (Emina (1F))
16A-8: 9:00-11:00 Symp. B: Recent Progress of Atomic Layer Processing (ALP) Technology	16B-8: 9:00-10:30 Nanocarbons II	16C-8: 9:00-11:00 Symp. D: BioMEMS, Lab on a Chip, and Nanobiotechnology	16D-8: 9:00-10:30 Nanofabrication I
Author's Interview: None	16B-8 Author's Interview: 12:05-12:15	Author's Interview: None	16D-8 Author's Interview: 11:50-12:00
Room P2 (Park Plaza BC (B2F))			
Coffee Break			
16A-9: 11:15-12:25 Nanoimprint, Hybrid-NIL, Biomimetics, and Functional Surfaces I	16B-9: 10:45-12:05 Nanocarbons III	16C-9: 11:15-12:15 BioMEMS, Lab on a Chip, and Nanobiotechnology I	16D-9: 10:50-11:50 Nanofabrication II
16A-9 Author's Interview: 12:25-12:35	16B-9 Author's Interview: 12:05-12:15	Author's Interview: None	16D-9 Author's Interview: 11:50-12:00
Lunch			
16A-10: 13:50-15:20 Nanoimprint, Hybrid-NIL, Biomimetics, and Functional Surfaces II	16B-10: 13:30-15:20 Nanocarbons IV	16C-10: 13:30-15:10 BioMEMS, Lab on a Chip, and Nanobiotechnology II	16D-10: 13:40-15:00 Nanofabrication III
16A-10 Author's Interview: 15:20-15:30	16B-10 Author's Interview: 15:20-15:30	16C-10 Author's Interview: 15:10-15:20	16D-10 Author's Interview: 15:00-15:10
Room P2 (Park Plaza BC (B2F))			
16P-11: 15:30-17:30 Poster Session II Nanocarbons, Nanodevices, Nanofabrication, Inorganic Nanomaterials, Nanoimprint, Hybrid-NIL, Biomimetics, and Functional Surfaces and BioMEMS, Lab on a Chip, and Nanobiotechnology			